

Title (en)

ELECTRON SOURCE WITH MICROTIPS, WITH FOCUSING GRID AND HIGH MICROTIP DENSITY, AND FLAT SCREEN USING SAME

Title (de)

MIKROSPITZEN-ELEKTRONENQUELLE MIT FOKUSSIERUNGSGITTER UND HOHER MIKROSPITZENDICHTE UND FLACHSCHIRM UNTER VERWENDUNG EINER SOLCHEN QUELLE

Title (fr)

SOURCE D'ELECTRONS A MICROPOINTES, A GRILLE DE FOCALISATION ET A DENSITE ELEVEE DE MICROPOINTES, ET ECRAN PLAT UTILISANT UNE TELLE SOURCE

Publication

**EP 1023741 B1 20060614 (FR)**

Application

**EP 98949053 A 19981013**

Priority

- FR 9802197 W 19981013
- FR 9712826 A 19971014

Abstract (en)

[origin: FR2769751A1] The upper focussing layer is set back from the extraction layer with a series of curved formations providing good focussing.

IPC 8 full level

**H01J 3/02** (2006.01); **H01J 3/18** (2006.01); **H01J 1/304** (2006.01); **H01J 9/02** (2006.01); **H01J 9/14** (2006.01); **H01J 29/04** (2006.01); **H01J 29/62** (2006.01); **H01J 31/12** (2006.01)

CPC (source: EP US)

**H01J 3/022** (2013.01 - EP US)

Designated contracting state (EPC)

DE GB IT

DOCDB simple family (publication)

**FR 2769751 A1 19990416**; **FR 2769751 B1 19991112**; DE 69834928 D1 20060727; DE 69834928 T2 20070201; EP 1023741 A1 20000802; EP 1023741 B1 20060614; JP 2001520437 A 20011030; JP 4220122 B2 20090204; US 6534913 B1 20030318; WO 9919896 A1 19990422

DOCDB simple family (application)

**FR 9712826 A 19971014**; DE 69834928 T 19981013; EP 98949053 A 19981013; FR 9802197 W 19981013; JP 2000516366 A 19981013; US 50954200 A 20000508